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Substituted Form 1449/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet 1 of 2

Complete if Known

Application Number	10/799,471
Filing Date	03/12/2004
First Named Inventor	Hai Q. Chiang
Art Unit	2815
Examiner Name	Joseph H. Nguyen
Attorney Docket Number	200315915-1

U. S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
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FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T ⁶
		Country Code ² Number ³ Kind Code ⁴ (if known)				
JN		EP1443130	08/04/2004	Japan Science		
		WO 03/010441	05/15/2003	Japan Science		
		WO 2004/034449	04/22/2004	DuPont		

Examiner
Signature

JOSEPH H. NGUYEN

Date
Considered

02/05/06

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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Substitute for form 1449/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>		Complete if Known	
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Examiner Name	Joseph H. Nguyen		
Attorney Docket Number	200315915-1		
Sheet	2	of	2

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
JN		OHTA, H. "Frontier of transparent oxide semiconductors", Solid State Electronics, vol 47, no. 12, December 2003, pgs. 2261-2267	
		MINAMI, T. "Transparent conductive multicomponent oxides films prepared by magnetron sputtering", Journal of Vacuum Science & Technology, vol 17, July 1999, pgs. 1765-1772	
		HIRAMATSU, H., "Electrical and Optical Properties of Radio-Frequency-Sputtered Thin Films of ((ZnO)5In2O3", Chemistry of Materials, vol 10, no 10, October 1998, pgs. 3033-3039	

Examiner Signature	JOSEPH H. NGUYEN	Date Considered	01/05/06
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